

CLEANROOM FUNDAMENTALS

Come join us to "Engineer the Microworld"

FREE COURSE

Open to UCI students & Cleanroom Users!



INTRODUCTION TO:

- Cleanroom Design
- Photolithography
- Dry Etching
- Wet Etching
- Dielectric Deposition (PECVD)
- Metal Deposition (Thin Film)
- Microscopy and Surface Measurement
- Surface Profilometry
- Back End Processing
- Wire bonding

APRIL 27
11AM - 3PM

LOCATION
Calit2, Room 3008

To register for a course, visit www.inrf.uci.edu/courses. For any questions, contact Dexter Humphrey at dexterh@uci.edu